

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of

Byong Kee KIM et al.

U.S. Patent Application No. 10/747,655

Filed: December 30, 2003

Confirmation No.: 1581

Group Art Unit: 1742

Examiner: Not yet assigned

For: PROCESS FOR MANUFACTURING NANO TAC-TRANSITION METAL BASED COMPOSITE POWDER

**REQUEST FOR CORRECTED FILING RECEIPT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a copy of the Filing Receipt received from the U.S. Patent and Trademark Office in the above-referenced application, on which we noticed that the priority data is listed erroneously. Also attached is a certified copy of the Priority Document listing the priority data, which should appear as:

*Application No. 10-2003-0028766, filed in the Republic of Korea on May 7, 2003.*

It is requested that a corrected filing receipt be issued.

Respectfully submitted,

LOWE HAUPTMAN GILMAN & BERNER, LLP

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UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
0747,655	12/30/2003	1742	900	1315-051	2	8	1

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JUL 09 2004

22429  
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1700 DIAGONAL ROAD  
SUITE 300 /310  
ALEXANDRIA, VA 22314

CONFIRMATION NO. 1581

UPDATED FILING RECEIPT



\*OC00000012715154\*

Date Mailed: 05/19/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Domestic Priority data as claimed by applicant

Foreign Applications

8766  
REPUBLIC OF KOREA 2003-26985 05/07/2003

If Required, Foreign Filing License Granted: 04/26/2004

RECEIVED

Projected Publication Date: 11/11/2004

MAY 20 2004

Non-Publication Request: No

Early Publication Request: No

Lowe, Hauptman, Gilman & Berner

Title

Process for manufacturing nano-phase TaC-transition metal based complex powder

DOCKETED BY  
DUE DATE

9

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Title 35, United States Code, Section 184  
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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대

한 민 국 특 허 청

KOREAN INTELLECTUAL  
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별첨 서본은 아래 출원의 원본과 동일함을 증명함.

This is to certify that the following application annexed hereto  
is a true copy from the records of the Korean Intellectual  
Property Office.

출 원 번 호 : 10-2003-0028766  
Application Number

출 원 년 월 일 : 2003년 05월 07일  
Date of Application MAY 07, 2003

출 원 인 : 한국기계연구원 외 1명  
Applicant(s) KOREA INSTITUTE OF MACHINERY & MATERIALS, et al



2004년 03월 10일

특 허 청

COMMISSIONER

